L Number	Hits	Search Text	DB	Time stamp
1	339	((348/300) or (348/301) or (348/308)).CCLS.	USPAT	2003/01/15 13:28
-	1504	(250/208.1).CCLS.	USPAT	2003/01/15 13:28
-	67	hatano-keisuke$.in. nakashiba-yasutaka$.in.	USPAT	2002/12/18 09:59
-	229	((250/208.1).CCLS.) and (insulat$3 adj (film$1 or layer$1)) same electrode$1	USPAT	2003/01/13 08:25
-	38	((250/208.1).CCLS.) and (insulat$3 adj (film$1 or layer$1)) same electrode$1 same isolat$3	USPAT	2002/12/18 10:56
-	38	((250/208.1).CCLS.) and (insulat$3 adj (film$1 or layer$1)) same electrode$1 same isolat$4	USPAT	2003/01/13 13:12
-	9	((250/214.1).CCLS.) and (insulat$3 adj (film$1 or layer$1)) same electrode$1 same isolat$4	USPAT	2003/01/13 13:31
-	38	((250/208.1).CCLS.) and (insulat$3 adj (film$1 or layer$1)) same electrode$1 same isolat$4	USPAT	2003/01/13 13:34
-	7	(((250/214.1).CCLS.) and (insulat$3 adj (film$1 or layer$1)) same electrode$1 same isolat$4) not (((250/208.1).CCLS.) and (insulat$3 adj (film$1 or layer$1)) same electrode$1 same isolat$4)	USPAT	2003/01/13 13:13
-	4	((250/214r).CCLS.) and (insulat$3 adj (film$1 or layer$1)) same electrode$1 same isolat$4	USPAT	2003/01/13 13:32
-	2	(((250/214r).CCLS.) and (insulat$3 adj (film$1 or layer$1)) same electrode$1 same isolat$4) not (((250/208.1).CCLS.) and (insulat$3 adj (film$1 or layer$1)) same electrode$1 same isolat$4)	USPAT	2003/01/13 13:32
-	17	(insulat$3 adj (film$1 or layer$1)) same isolat$4 near2 electrode$1 and 250/$.ccls.	USPAT	2003/01/13 13:45
-	630	(insulat$3 adj (film$1 or layer$1)) same isolat$4 near2 electrode$1 and 257/$.ccls.	USPAT	2003/01/15 09:30
-	624	((insulat$3 adj (film$1 or layer$1)) same isolat$4 near2 electrode$1 and 257/$.ccls.) not ((insulat$3 adj (film$1 or layer$1)) same isolat$4 near2 electrode$1 and 250/$.ccls.)	USPAT	2003/01/13 13:46
-	624	(((insulat$3 adj (film$1 or layer$1)) same isolat$4 near2 electrode$1 and 257/$.ccls.) not ((insulat$3 adj (film$1 or layer$1)) same isolat$4 near2 electrode$1 and 250/$.ccls.)) not (((250/208.1).CCLS.) and (insulat$3 adj (film$1 or layer$1)) same electrode$1 same isolat$4)	USPAT	2003/01/14 14:20
-	5	("4751559" | "4812869" | "5010245" | "5029998" | "5483318").PN.	USPAT	2003/01/14 10:30
-	1984	(electrode$1) with polysilicon with silicide	USPAT	2003/01/14 14:33
-	3	(isolat$3 adj electrode$1) with constant with voltage$1	USPAT	2003/01/14 14:42
-	0	(isolat$3 adj electrode$1) with constant with voltage$1	EPO; JPO; DERWENT; IBM_TDB	2003/01/14 14:42
-	28	(isolat$3 adj electrode$1) with voltage$1	EPO; JPO; DERWENT; IBM_TDB	2003/01/14 14:49
-	13	sasaki-michio$.in.	USPAT	2003/01/14 14:49
-	0	insulat$3 same flow$3 same heat$3 same electrode$1 same flatten$3 same etch$3 same bury$3	USPAT	2003/01/15 07:59

-	1	insulat$3 same heat$3 same electrode$1 same flatten$3 same etch$3 same bury$3	USPAT	2003/01/15 08:00
-	9	insulat$3 same heat$3 same flatten$3 same etch$3 same bury$3	USPAT	2003/01/15 08:07
-	1	insulat$3 same heat$3 same flatten$3 same etch$3 same (bury$3 or buried) same electrode$1	USPAT	2003/01/15 08:07
-	8	insulat$3 same heat$3 same flatten$3 same etch$3 same (bury$3 or buried) same electrode$1	EPO; JPO; DERWENT; IBM_TDB	2003/01/15 08:10
-	3	insulat$3 same heat$3 same flatten$3 same (bury$3 or buried) same electrode$1	USPAT	2003/01/15 08:12
-	15	insulat$3 same heat$3 same flatten$3 same (bury$3 or buried) same electrode$1	EPO; JPO; DERWENT; IBM_TDB	2003/01/15 08:24
-	133	insulat$3 with (bury$3 or buried) same electrode$1 same heat$3	USPAT	2003/01/15 08:24
-	26	insulat$3 with (bury$3 or buried) same electrode$1 same heat$3 and flatten$3	USPAT	2003/01/15 08:25
-	15	insulat$3 with (bury$3 or buried) same electrode$1 same heat$3 and flatten$3 same heat$3	USPAT	2003/01/15 08:29
-	4	insulat$3 with (bury$3 or buried) with (flow$3 or heat$3) same electrode$1 and flatten$3 with heat$3	USPAT	2003/01/15 08:31
-	130	insulat$3 with (flow$3 or heat$3) same electrode$1 and flatten$3 with heat$3	USPAT	2003/01/15 08:31
-	5	insulat$3 with (flow$3 with heat$3) same electrode$1 and flatten$3 with heat$3	USPAT	2003/01/15 08:46
-	35	(insulat$3 or bpsg) with (reflow$3) same electrode$1 and (flatten$3 or flat) with heat$3	USPAT	2003/01/15 08:48
-	23	(insulat$3 adj (film$1 or layer$1)) same isolat$4 near2 electrode$1 and 348/$.ccls.	USPAT	2003/01/15 09:31

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